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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Won Sun Shin et al.
Assignee: Amkor Technology, Inc.
Title: SEMICONDUCTOR PACKAGE AND METHOD FOR FABRICATING
THE SAME
Serial No.: 10/785,528 Filed: February 24, 2004
Examiner: Unassigned Group Art 2811
Unit:
Docket No.: GK001102

Monterey, CA
April 8, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT
UNDER §1.97(b)

Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant(s) wish to call the following documents (a copy of each is enclosed) to the attention of the Examiner:

FOREIGN DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY
1)	KR1997-0019144	5/17/1997	Rep. Of Korea
2)	KR1996-0009776	4/01/1996	Rep. Of Korea

A PTO form 1449 listing these documents is enclosed. The relevance of the non-English language documents is set forth in the enclosed English translations of the abstracts.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;

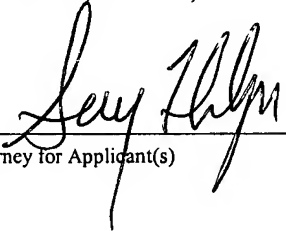
2. a representation that a search has been made, other than as described above; or

3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

The Commissioner is hereby authorized to charge any fees required for consideration of this Information Disclosure Statement, and to credit any overpayment of fees to Deposit Account No. 50-0553.

CERTIFICATE OF MAILING

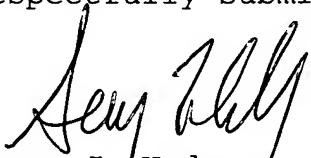
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 8, 2005.



Attorney for Applicant(s)

April 8, 2005
Date of Signature

Respectfully submitted,


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Form PTO-1449

Atty Docket No.

Serial No.

GK001102

10/785,528

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

Applicant(s)

Won Sun Shin et al.

Filing Date

February 24, 2004

Group

2811

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

							Translation	
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
	AL	KR1997-0019144	5/17/1997	Rep. Of Korea			abst	
	AM	KR1996-0009776	4/01/1996	Rep. Of Korea			abst	
	AN							
	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
	AT	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).